June 5, 2001

BOX PATENT APPLICATION Commissioner for Patents Washington, D.C. 20231

Re:

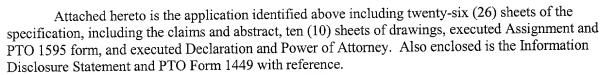
Application of Kenji Matsumoto

SEMICONDUCTOR LASER AND FABRICATING METHOD OF THE SAME

Assignee: FUJI PHOTO FILM CO., LTD.

Our Ref. Q64809

Dear Sir:



The Government filing fee is calculated as follows:

| Total claims | 5 - | 20 | = | X | \$18.00 | = | \$.00_ |
|--------------------|-----|----|-----|-----|---------|---|----------|
| Independent claims | 4 - | 3 | = 1 | _ x | \$80.00 | = | \$80.00 |
| Base Fee | | | | _ | | | \$710.00 |

TOTAL FILING FEE\$790.00Recordation of Assignment\$40.00TOTAL FEE\$830.00

Checks for the statutory filing fee of \$790.00 and Assignment recordation fee of \$40.00 are attached. You are also directed and authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this transmittal letter is attached.

Priority is claimed from June 5, 2001, based on Japanese Application No. (patent) 167710/2000. The priority document is enclosed herewith.

Respectfully submitted,

SUGHRUE, MION, ZINN,

MACPEAK & SEAS, PLLC

Attorneys for Applicant

Darryl Mexic

Registration No. 23,063

DM/amt/tmm



